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S Magoshi, H Niiyama, S Sato, Y Kato, Y Watanabe, ... - Jpn. J. Appl. Phys, 1999 - jjap.ipap.jp

... **Shunko Magoshi**, Hiromi Niiyama, Shinji Sato, Yoshimitsu Kato, Yumi Watanabe, Tohru ...

Fabricating Sub-100-nm Complementary Metal-Oxide-Semiconductor Devices using ...

Cited by 1 - Cached - Web Search - BL DirectHigh-speed electron beam data conversion system combining hierarchical operation with parallel ... - group of 2 »

S Magoshi, K Koyama, O Ikenaga, S Watanabe, T ... - JPN J APPL PHYS PART 1 REGUL PAP SHORT NOTE., 1992 - csa.com

**Shunko Magoshi**, Kiyomi Koyama, Osamu Ikenaga, Susumu Watanabe, Tamaki Saito, Shinji Sakamoto, Shin-ichiro ... 2 Semiconductor Devices and Integrated Circuits; E 932 ...Web Search - BL DirectThroughput Enhancement Strategy of Maskless Electron Beam Direct Writing for Logic Device - group of 2 »

R Inanami, S Magoshi, S Kousai, M Hamada, T ... - INTERNATIONAL ELECTRON DEVICES MEETING, 2000 - ieeexplore.ieee.org

... Ryōichi Inanami, **Shunko Magoshi**, Shohei Kousai", Mototsugu Hamada", Toshinari

Takayanagi ... bess &amp; Manufacturing Engineering Center, Semiconductor Company, Toshiba ...

Web Search - BL DirectStress-Induced Voiding Phenomena for an actual CMOS LSI Interconnects

H NAKAZAWA, M MORITA - ieeexplore.ieee.org

... **Semiconductor** Company. ... Ms. Sachiko Itoh. Mr. **Shunko Magoshi**, and Mr. Masayuki Hatano in TOSHIBA Corporation for their help with the experiment and discussion. ...Web Search[Google Home](#) - [About Google](#) - [About Google Scholar](#)

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**Silicon Interposer Technology for High-Density Package - group of 2 »**

M Matsuo, N Hayasaka, K Okumura, E Hosomi, C ... - ELECTRONIC COMPONENTS AND TECHNOLOGY CONFERENCE, 2000 - ieeexplore.ieee.org

... jp \*\*Advanced Packaging Engineering Depart., Semiconductor Company, Toshiba ... in turn, leads to shrinking **design** rule of ... probes and an HP-8720D **network** analyzer. ...[Cited by 1](#) - [Web Search](#) - [BL Direct](#)**High-density plasma chemical vapor deposition of silicon-based dielectric films for integrated ... - group of 3 »**

SV Nguyen - IBM JOURNAL OF RESEARCH AND DEVELOPMENT, 1999 - research.ibm.com

... Besides parameters associated with the **design** of the ... the formation of a porous oxide **network** and hole ... to thank the IBM Advanced **Semiconductor** Technology Center ...[Cited by 8](#) - [Cached](#) - [Web Search](#) - [BL Direct](#)semiconductor design network "Katsuya Okumura" [Google Home](#) - [About Google](#) - [About Google Scholar](#)

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Sugihara, M.; Takata, T.; Nakamura, K.; Inanami, R.; Hayashi, H.; Kishimoto, K.; Kawano, Y.; Matsunaga, Y.; Murakami, K.; Okumura, K.; [System-on-Chip, 2005. Proceedings. 2005 International Symposium on](#)  
15-17 Nov. 2005 Page(s):137 - 140

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Nakasugi, T.; Ando, A.; Inanami, R.; Sasaki, N.; Sugihara, K.; [Micropocesses and Nanotechnology Conference, 2001 International](#)  
31 Oct.-2 Nov. 2001 Page(s):302 - 303  
Digital Object Identifier 10.1109/IMNC.2001.984209

[AbstractPlus](#) | Full Text: [PDF\(269 KB\)](#) [IEEE CNF Rights and Permissions](#) 3. **Throughput enhancement strategy of maskless electron beam direct write device**

Inanami, R.; Magoshi, S.; Kousai, S.; Hmada, M.; Takayanagi, T.; Sugihara, K.; Kuroda, T.; [Electron Devices Meeting, 2000. IEDM Technical Digest. International](#)  
10-13 Dec. 2000 Page(s):833 - 836  
Digital Object Identifier 10.1109/IEDM.2000.904446

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Inanami, R.; Nakasugi, T.; Sato, S.; Mimotogi, S.; Tanaka, S.; Sugihara, K.; [Micropocesses and Nanotechnology Conference, 1999. Digest of Papers. Micro/Nanotechnology '99, 1999 International](#)  
6-8 July 1999 Page(s):38 - 39

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[Electron Devices Meeting, 2000, IEDM Technical Digest, International](#)

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5. **Improved Electron-Beam / DUV Intra-Level Mix-and-Match As A Productic Lithography With 100-nm Resolution**

Magoshi, S.; Niiyama, H.; Sato, S.; Kato, Y.; Watanabe, Y.; Shibata, T.; Ito, M.  
Nakasugi, T.; Sugihara, K.; Okumura, K.[Micropocesses and Nanotechnology Conference, 1998 International](#)

13-16 July 1998 Page(s):42 - 43

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6. **Charge Reducing Effect Of Chemically Amplified Resist**

Nakasugi, T.; Magoshi, S.; Sugihara, K.; Saito, S.; Kihara, N.

[Micropocesses and Nanotechnology Conference, 1998 International](#)

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13	BRS	L21	725	703/6.ccls.
14	BRS	L22	511	(character adj projection)
15	BRS	L23	8	(character adj projection) same (internet or intranet or network)
16	BRS	L24	51	(character adj projection) same (semiconduct\$2)
17	BRS	L25	0	(character adj projection) same (semiconduct\$2) same (internet or netork)
18	BRS	L26	316	703/6.ccls.and network
19	BRS	L27	332	703/6.ccls.and (network or Internet or Intranet)
20	BRS	L28	68	703/6.ccls.and (network or Internet or Intranet) and semiconductor
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22	BRS	L30	3	703/6.ccls.and (network or Internet or Intranet) and semiconductor and circuits and aperture
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26	BRS	L34	1	(program adj product) and (semiconductor adj device) and (purchase same (network or Intranet)) and (record\$3 same medium)
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